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*Admitted only in Maryland
*Admitted only in Virginia
*Practice limited to
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Re: Allowed U.S. Utility Patent Application
Appl. No. 10/677,242; Filed: October 3, 2003
For: **Method and Systems for Total Focus Deviation Adjustments on Maskless
Lithography Systems**
Inventor: Peter Kochersperger
Our Ref: 1857.2060000

Sir:

In response to the Notice of Allowance and Fee(s) Due dated April 16, 2008, the following documents are transmitted for appropriate action by the U.S. Patent and Trademark Office:

1. Issue Fee Transmittal (Form PTOL-85);
2. Online Credit Card Payment Authorization for **\$1,743.00** to cover:
\$1,440.00 Issue Fee;
\$300.00 Publication Fee; and
\$3.00 Advance copy of patent.

The above-listed documents are filed electronically through EFS-Web.

Fee payment is provided through online credit card payment. The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

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MKH/srb
Enclosures

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